

## SLPC2026 Session Chairs List

| Session number & title                            | Session chair |                            | Affiliation   |
|---|---------------|----------------------------|---|
| Opening Remark                                    | 塚本 雅裕         | <b>Masahiro Tsukamoto</b>  | JWRI, The University of Osaka, Japan  |
| 1. Direct Energy Deposition                       | 溝尻 瑞枝         | <b>Mizue Mizoshiri</b>     | Nagaoka University of Technology, Japan   |
|   | 酒井 俊明         | <b>Toshiaki Sakai</b>      | FURUKAWA ELECTRIC CO., LTD., Japan  |
| 2. Additive Manufacturing/Selective Laser Melting | 山下 順広         | <b>Yorihiro Yamashita</b>  | University of Fukui, Japan  |
|   |               | <b>Jörg Volpp</b>          | Luleå University of Technology, Sweden  |
| 3. Surface modification 1                         | 竹中 啓輔         | <b>Keisuke Takenaka</b>    | JWRI, The University of Osaka, Japan  |
|   | 甲藤 正人         | <b>Masahito Katto</b>      | University of Miyazaki, Japan   |
| 4. Plenary Session                                | 塚本 雅裕         | <b>Masahiro Tsukamoto</b>  | JWRI, The University of Osaka, Japan  |
| 5. Transparent Materails                          | 宮地 悟代         | <b>Godai MIYAJI</b>        | Tokyo University of Agriculture and Technology, Japan   |
|   | 岡本 泰寛         | <b>Yasuhiro Okamoto</b>    | Hiroshima University, Japan   |
| 6. Beam Shaping                                   | 竹中 啓輔         | <b>Keisuke Takenaka</b>    | JWRI, The University of Osaka   |
|   | 津山 美穂         | <b>Miho Tsuyama</b>        | Kindai University, Japan  |
| 7. Surface Modification 2                         | 橋田 昌樹         | <b>Masaki Hashida</b>      | Tokai University/Kyoto University, Japan  |
|   |               | <b>Beat Neuenschwander</b> | Bern University of Applied Sciences, Institute for Applied Laser, Photonics and Surface Technologies ALPS |
| 8. Laser Manufacturing                            | 奈良崎 愛子        | <b>Aiko Narazaki</b>       | National Institute of Advanced Industrial Science and Technology, Japan                                   |
|   |               | <b>Timotius Pasang</b>     | Western Michigan University, USA  |
| 9. Femtosecond Laser Processing                   | 伊藤 祐介         | <b>Yusuke Ito</b>          | The University of Tokyo, Japan  |
|   | 長谷川 智士        | <b>Satoshi Hasegawa</b>    | Utsunomiya University, Japan  |
| 10. Short pulse & UV laser processing             | 甲藤 正人         | <b>Masahito Katto</b>      | University of Miyazaki, Japan   |
|   | 塚本 雅裕         | <b>Masahiro Tsukamoto</b>  | JWRI, The University of Osaka, Japan  |
| Award Ceremony and Closing Remarks of SLPC        | 塚本 雅裕         | <b>Masahiro Tsukamoto</b>  | JWRI, The University of Osaka, Japan  |

(敬称略)